



MIT9922

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**APPLICANT:** Menon et al. **GROUP:** 2881  
**SERIAL NO:** 10/624,316 **EXAMINER:** Berman, Jack I.  
**FILED:** 07/21/2003  
**FOR:** SYSTEM AND METHOD FOR MASKLESS LITHOGRAPHY USING  
AN ARRAY OF IMPROVED DIFFRACTIVE FOCUSING ELEMENT

Mail Stop RCE  
Assistant Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PRELIMINARY AMENDMENT**

Responsive to the Final Office Action mailed on January 27, 2005, and in connection with the Request for Continued Examination filed herewith, please amend the above-identified application as follows: